

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	("6110648").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/05/23 09:17
L2	0	(patterned near silicon same etching near residues and oxygen same silicon near etching and etching near3 buffer same residues same thickness).clm.	US-PGPUB; USPAT	OR	OFF	2007/05/23 09:18